

ABSTRACT

A method of manufacturing plasma display panels using substrate holder (1) for deposition on a substrate (13) of the plasma display panel. Substrate holder (1) is configured with plural frames (2), and substrate (13) of the plasma display panel is held by its periphery with at least one of these frames (2). Frame (2) holding substrate (13) has protrusion (5) extending to non-deposition face (13b) of the substrate held in such a way as to surround substrate (13). Since protrusion (5) acts as a blocking sheet, attachment of a deposition material passing through opening (4) on substrate holder (1) and reaching onto non-deposition face (13b) of substrate (13) is suppressed.